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## APPLICANTS

Yosuke Inomata, Yokaichi-shi, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\*

None / EC

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-19535 01/28/2003

EC

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
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Verified and Acknowledged	JAPAN	6	6	2
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## ADDRESS

000026021  
HOGAN & HARTSON L.L.P.  
500 S. GRAND AVENUE  
SUITE 1900  
LOS ANGELES , CA  
90071-2611

## TITLE

Multicrystalline silicon substrate and process for roughening surface thereof

FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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